

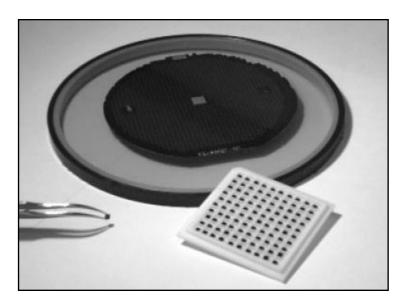
SM-5103 Low Pressure Silicon Die

Description

The SM-5103 is a silicon micromachined, piezoresistive low pressure sensing chip. These devices are available in full-scale ranges from 0.3 to 3.0 PSI and are ideal for OEM and high volume applications.

Provided in die form, these sensors can be mounted on ceramic or PC board substrates as part of an OEM system. They also may be packaged into proprietary, or applicationspecific sensor lines.

Die are probed, inked and diced, and shipped on tape or in waffle packs.



Features

- Low pressure 0.3 to 3.0 PSI
- High performance at low pressures
- Constant current or constant voltage drive
- Low cost
- High millivolt output

Applications

- Air flow
- Level detection
- HVAC
- Instrumentation
- · Gas analysis

Characteristics

All parameters measured at 5 volts excitation at room temperature, unless otherwise specified.

Parameter	Min	Тур	Max	Units
Excitation Voltage	0	5.0	10.0	Volts
Excitation Current	0	1.5	3.0	mA
Span (FS Range) ¹				
0.3 PSI	25	50	75	mV
0.8 PSI	25	50	75	mV
1.5 PSI	25	50	75	mV
3.0 PSI	25	50	75	mV
Offset	-50	0	50	mV
TC Span ²		-22±5		%FS/100°C
TC Offset ²		±12		%FS/100°C
Linearity ³	-0.3	±0.1	0.3	%FS
Bridge Impedance	2.7	3.3	4.0	k
TC Resistance		28±5		%FS/100°C
Proof Pressure	3X			Rated FS Pressure
Burst Pressure⁴	5X			Rated FS Pressure
Operating Temp	-40		85	°C
Storage Temp	-55		125	°C

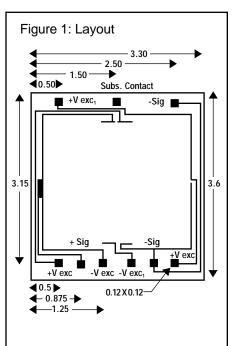
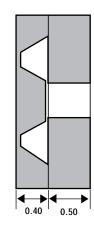
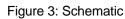
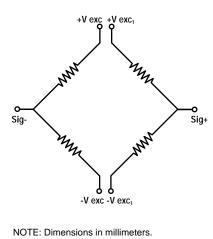


Figure 2: Side View







Ordering Information

2) Measured from 0 to 70 °C.

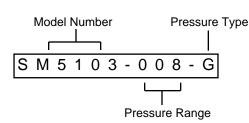
1) Measured at 5.0 V constant voltage excitation.

4) Burst Pressure in excess of 20X when topside pressured

3) Defined as the best fit straight line; 0.3 PSI linearity is ±0.5% FS (max).

Notes

Pressure range	Pressure type
003: 0.3 PSI	G: Gage
008: 0.8 PSI	
015: 1.5 PSI	
030: 3.0 PSI	



Special configurations are available. Contact Silicon Microstructures for more information.



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Additional Products

- Accelerometers
- OEM Pressure Transducers
- Custom Designed Products
- Surface Mount Pressure Sensors

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